

Reviewer Acknowledgements

Modern Applied Science wishes to acknowledge the following individuals for their assistance with peer review of manuscripts for this issue. Their help and contributions in maintaining the quality of the journal are greatly appreciated.

Modern Applied Science is recruiting reviewers for the journal. If you are interested in becoming a reviewer, we welcome you to join us. Please find the application form and details at <http://www.ccsenet.org/reviewer> and e-mail the completed application form to mas@ccsenet.org.

Reviewers for Volume 9, Number 8

Alexey Naidenov, Institute of Economics of the Ural Branch of the Russian Academy of Sciences, Russia

Anatoliy S. Semenov, Perm State Agricultural Academy, Russia

Anna Grana, University of Palermo, Italy

Awangku Hassanal Bahar Bin Pengiran Bagul, Universiti Malaysia Sabah, Malaysia

B.Bharathi, Sathyabama University, Chennai, India

H.Yegorov, Academic Research Institute, Russia

J. Eric Jensen, Harvard Medical School / McLean Hospital, Canada

Jardi Andaki, University of Sam Ratulangi, Indonesia

Juan José Villaverde, National Institute for Agricultural and Food Research and Technology, Spain

Levent Kurt, The City University of New York, USA

Malygina Natalia, Ural Federal University, Russia

Marek Brabec, Academy of Sciences of the Czech Republic, Czech Republic

Marek Brabec, Academy of Sciences of the Czech republic, Czech Republic

Mikhail Dudin, Russian academy of Entrepreneurship, Russia

Naumov I. V., Institute of Economics of the Ural Branch of the Russian Academy of Sciences, Russia

Olga Artemenko, Kaluga branch of Bauman Moscow State Technical University, Russia

Saiful Darman, University of Tadulako, Indonesia

Sergey Subachev, Emergencies and Elimination of Consequences of Natural Disasters, Russia

Tharek Abd. Rahman, Universiti Teknologi Malaysia, Malaysia

Yating Hu, Middle Tennessee State University, USA

Yonghong Meng, Shaanxi Normal University, China

Yury Subachev, Institute of Engineering Science, Russia